

RYUKA.007AUS.

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Shin-Ichi Hashimoto et al.)	Art Unit 2881
)	
Appl. No.	:	10/672,469)	
)	
Filed	:	September 26, 2003)	
)	
For	:	ELECTRON BEAM EXPOSURE)	
		APPARATUS, DEFLECTION)	
		APPARATUS, AND ELECTRON)	
		BEAM EXPOSURE METHOD)	
)	
Examiner	:	Anthony G. Quash)	
)	

AMENDMENT

Hon. Commissioner
of Patents and Trademarks
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the office action mailed October 5, 2004 from the United States Patent and Trademark Office for the above-identified patent application. Please make the following changes: